

6/8wafer Fully automatic cassette cleaning machine

Model: SA-CCM-48LS

SA-CCM-48LS adopts flame-retardant material with excellent leakproof performance. It is equipped with comprehensive safety interlock and alarm systems for secure operation. Featuring stable running performance and low failure rate, it can connect with management systems. Following strict industrial standards, it delivers long-term reliable service for semiconductor supporting production.



Feature

- Long-time Acidic Corrosion Resistant
- Double-layer Leak-proof
- Customize for Manual and Fully Automatic
- Support MES system
- Three-system Quality Control

Application

- Wafer Front-End Cleaning
- Photolithography Cleaning
- Etch Post-Cleaning
- Thin Film Cleaning
- Back-End Packaging

Specifications:

Parameter	Descriptions
Wafer Size	6"/8"
Cleaning Capacity	cassete:8pieces/batch basket:16pieces/batch
Up Time	≥98%
MTTR	<2hrs
MTBF	≥400hrs
Control Part	PLC and HMI